

Notice of References Cited

Application/Control No.

09/490,448

Applicant(s)/Patent Under
Reexamination
NAKAMURA ET AL.

Examiner

Kim T. Huynh

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,922,056 A	07-1999	Amell et al.	710/16
	B	US-5,991,542 A	11-1999	Han et al.	717/167
	C	US-5,383,147 A	01-1995	Sanemitsu, Yoshikado	365/52
	D	US-2002/0023189	02-2002	Fensore et al.	710/305
	E	US-5,170,471	12-1992	Bonevento et al.	710/17
	F	US-4,591,973	05-1986	Ferris et al.	710/3
	G	US-6,269,292	07-2001	Kokubu et al.	701/35
	H	US-6,209,023	03-2001	Dimitroff et al.	709/211
	I	US-6,176,422	01-2001	Hattori, Yutaka	235/375
	J	US-5,922,056	07-1999	Amell et al.	710/16
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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